

Notice of References Cited	Application/Control No. 10/643,063		Applicant(s)/Patent Under Reexamination CHOI ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0046027	11-2001	TAI et al.	349/159
	B	US-			
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FOREIGN PATENT DOCUMENTS

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